

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: David C. Fairbourn

Art Unit: 1762

Serial No.: 10/613,620

Examiner: Bret P. Chen

Filed: July 3, 2003

For: SIMPLE CHEMICAL VAPOR DEPOSITION SYSTEM AND METHODS FOR
DEPOSITING MULTIPLE-METAL ALUMINIDE COATINGS**Petition for Extension of Time**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.136(a), Applicant respectfully petitions for an extension of time of one (1) month from the original response date of December 20, 2006 for responding to the outstanding Office Action in the above-identified patent application. With the extension of time, the period for response now extends up to and includes January 12, 2007.

If any additional charges or credits are necessary to complete this communication, please apply them to Deposit Account 23-3000.

Respectfully submitted,

/William R. Allen/
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